

**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: FRANCISCO ARIAS

APPLICATION No.: 10/727,124

FILING DATE: DECEMBER 3, 2003

FOR: METHOD OF MANUFACTURING  
MICRONEEDLE STRUCTURES USING  
PHOTOLITHOGRAPHY

EXAMINER: VARGOT, MATHIEU D.

ART UNIT: 1791

CONF. No: 4751

**Transmittal of Issue Fee and Advance Order**Mail Stop Issue Fee  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance dated March 10, 2010 applicant herewith submits the following:

- ☒ Form PTOL-85B (2)
- ☒ Deposit account Number 50-4616 to be charged in the amount of \$1810.00 covering the following fees due:
  - 1) Issue Fee \$1510.00 (37 CFR 1.18(a)); 2) Publication Fee (37 CFR 1.18(d)): \$300.00
- ☒ Communication
- ☒ Return Postcard

The Commissioner is hereby authorized to charge any deficiency or credit any overpayment of fees due for timely filing of these papers to Deposit Account No. 50-4616.

Respectfully submitted,  
King & Spalding,Susan L. Harlocker  
Registration No. 59,144Date: June 10, 2010**Correspondence Address:**  
Customer No. 79975